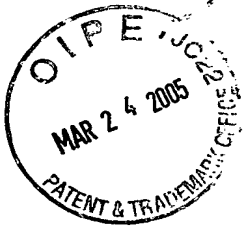


IFW)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Patent Application of

Chuong Vu

Application No. 10/690,177

Filed: **October 20, 2003**For: Joining Material Stencil and
Method of Use

Group Art Unit: 2822

Examiner: Guerrero, Maria F.

RESPONSE TO RESTRICTION REQUIREMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action including a Restriction Requirement mailed on
February 25, 2005, please consider the following.